

<b>Notice of References Cited</b>	Application/Control No. 10/773,822	Applicant(s)/Patent Under Reexamination HEDHLI ET AL.	
	Examiner David Turocy	Art Unit 1762	Page 1 of-1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,077,621	06-2000	Allen et al.	429/33
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	R					
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	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kirk-Othmer Encyclopedia of Chemical Technology. "Thin Films, Film Formation Techniques". Section 2 "Thin Films from Vapors". December 4, 2000
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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